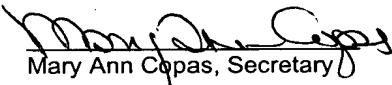




IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 14, 2003.


Mary Ann Capas, Secretary

In the Application of Wilfred Lerch et al

Ser.No.: 09/980,754

Filed: February 15, 2002

For: METHOD OF GENERATING DEFECTS IN A LATTICE STRUCTURE OF
A SEMI-CONDUCTOR MATERIAL

Art Unit: 2823

Examiner: Julio J. Maldonado

Commissioner for Patents
Alexandria VA 22313-1450

AMENDMENT IN RESPONSE TO OFFICE ACTION DATED 07/15/2003

Dear Sir:

In response to the outstanding Office Action, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.